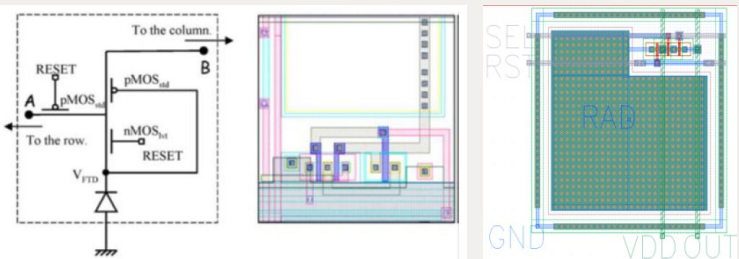


**DIPARTIMENTO DI INGEGNERIA
CORSO DI DOTTORATO IN INGEGNERIA INDUSTRIALE E
DELL'INFORMAZIONE -
PHD COURSE IN INDUSTRIAL AND INFORMATION ENGINEERING -
37TH CYCLE**

<p>Title of the research activity:</p>	<p>Advanced Radiation Sensors and Readout CMOS Architectures for applications in harsh environment</p> <p><i>Research Field: Sensors and Electronics, Medical, Space and Physics applications.</i></p> <p><i>International and National Collaborations: CERN (European Organization for Nuclear Research, Switzerland); LFoundry (Avezzano, Italy), INFN (Istituto Nazionale di Fisica Nucleare, Italy).</i></p> <p><i>International and National Projects: CERN RD53 International Collaboration, EU AIDAInnova Horizon Europe, INFN FOOT, ARCADIA projects.</i></p>
<p>State of the Art:</p>	<p>Present radiation pixel sensors and related read-out electronics forces to face some critical issues in the microelectronics design as follows:</p> <ul style="list-style-type: none"> - the increased number of read-out channels forces to have more accurate power budget (reduced power consumption of each channel). - the increased number of read data forces to develop advanced algorithms for data handling - any integrated circuit will be exposed to extremely large radiation dose, up to 1 Grad in 10 years. <p>Optimal IC design is therefore required for high-performance, low-power and low-cost systems. These results can be achieved with a custom design and performance optimization since different experiments and applications require different specifications in terms, for instance, of radiation hardness, power supply, power consumption, accuracy.</p>
<p>Short description and objectives of the research activity:</p>	<p>The purpose of the present research is to exploit innovative CMOS technologies options [Wang-2017, Beckers-2018] in terms of:</p> <ul style="list-style-type: none"> - minimum gate size (65nm, 45nm, 32nm, 28nm, or below) - technology features (CMOS-bulk, CMOS-FinFET, CMOS-SOI, etc...) - technology access & cost (this is in terms not only of prototyping for investigation, but also for the final production) <p>This will enable:</p> <ul style="list-style-type: none"> - higher digital circuit density to includes more digital functionalities - higher speed to achieve improved performance in term of larger bandwidth, enabling new application <p>In particular, the main outcome of the project is to develop innovative CMOS monolithic pixel detectors that can replace standard hybrid pixel and silicon strip detectors in a wide range of applications such as High Energy Physics experiments, Medical applications as well as Space applications.</p> <p>The proposed development relies on three key elements:</p> <ul style="list-style-type: none"> - a sensor fabrication technology that, starting from the experience gained in the previous research activity within national and international collaborations and projects, will improve in such a way to be suitable for a wide range of applications. - a set of smaller-size test structures to investigate relevant issues that can be addressed without full-size prototypes (e.g. radiation resistance, monitoring of the substrate properties, influence of different pixel's architectures on charge collection efficiency).

	<p>– a versatile and scalable front-end electronics and architectures, capable to effectively support the development of sensors with realistic size and performances.</p> <p>The CMOS electronics will be common to the different sensor options, that will be explored by changing only the substrate material and/or some step of the production process.</p> <p>All the design improvements and modifications introduced in the process flow will be validated with the help of Technology Computer-Aided Design (TCAD) simulations, relying on process data provided by the foundry. A proper TCAD modeling of the bulk and surface radiation damage effect should also be devised and validated for the selected technology [Moscattelli-2016], thus fostering its application for the comparison of different layout/doping profiles aiming at optimizing the radiation resistance of the device in terms of SNR and breakdown effects.</p> <p>Aiming at low power design, alternative pixel front-end architectures will be investigated [Placidi-2016]. A so-called Weak Inversion Pixel Sensor (WIPS), shown in Fig. 1, exploits a dedicated, yet simple circuitry, based on a pre-charge/evaluation scheme, which allows for “sparse” access mode and thus for speeding-up the read-out phase [Passeri-2004].</p>  <p>Fig. 1: CMOS WIPS scheme: equivalent circuit (left-hand side), corresponding layout (right-hand side)</p>
<p>Bibliography:</p>	<p>[Beckers-2018] A. Beckers et al. “Characterization and Modeling of 28-nm Bulk CMOS Technology Down to 4.2 K”, IEEE Journal of the Electron Devices Society, Year: 2018, Volume: 6</p> <p>[Wang-2017] T. Wang et al., “Development of a Depleted Monolithic CMOS Sensor in a 150 nm CMOS Technology for the ATLAS Inner Tracker Upgrade”, JINST 12 (2017) C01039.</p> <p>[Passeri-2004] D. Passeri, P. Placidi, M. Petasecca, P. Ciampolini, G. Matrella, A. Marras, A. Papi, G.M.Bilei, “Design, Fabrication, and Test of CMOS Active-Pixel Radiation Sensors”, IEEE TRANSACTIONS ON NUCLEAR SCIENCE, VOL. 51, NO. 3, JUNE 2004.</p> <p>[Placidi-2016] E. Conti, S. Marconi, T. Hemperek, J. Christiansen and P. Placidi, “Performance evaluation of digital pixel readout chip architecture operating at very high rate through a reusable UVM simulation framework”, Proc. of NSS (2016).</p> <p>[Moscattelli-2016] F. Moscatelli et al., “Combined Bulk and Surface Radiation Damage Effects at Very High Fluences in Silicon Detectors: Measurements and TCAD Simulations”, IEEE Trans. on Nucl. Sci.63 (5), (2016) 2716-2723.</p>
<p>Scientific coordinator (s)</p>	<p>Daniele PASSERI, Pisana PLACIDI</p>
<p>Contact (s)</p>	<p>Daniele PASSERI: daniele.passeri@unipg.it, Ph: +39-075-5853643 https://www.unipg.it/personale/daniele.passeri</p> <p>Pisana PLACIDI: pisana.placidi@unipg.it, Ph: +39-075-5853636 https://www.unipg.it/personale/daniele.passeri</p>